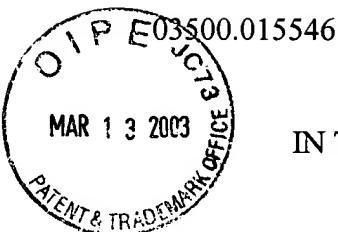


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GROUP 1700

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
TOSHIYASU SHIRASUNA ET AL. )  
Application No.: 09/899,188 )  
Filed: July 6, 2001 )  
For: PLASMA TREATMENT, )  
METHOD AND PLASMA )  
TREATMENT APPARATUS )  
Examiner: Thi D. Dang  
Group Art Unit: 1763  
March 12, 2003

Commissioner for Patents  
Washington, D.C. 20231

AMENDMENT

Sir:

a) Introductory Comments

This Amendment is filed in accordance with the OG Notice-1267 Off..Gaz Pat.Office 106 of February 25, 2003 in which 37 C.F.R. §1.121(a)-(d) is waived for amendments to the application where the Amendment complies with the Revised Amendment Format of the OG Notice.

In response to the outstanding Office Action mailed December 13, 2002, please amend the subject application as follows: